

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(Case No. 98,162-B)

In re Application of: )  
DeGendt, et al. )  
Serial No.: 09/207,546 ) Group Art Unit: 1746  
Filed: December 8, 1998 ) Examiner: Ahmed  
For: METHOD FOR REMOVING ORGANIC )  
CONTAMINANTS FROM A )  
A SEMICONDUCTOR SURFACE )

Commissioner for Patents  
Washington, D.C. 20231

**OFFICIAL**

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GROUP 1700

13/B  
8-29-01

Dear Sir:

In response to the outstanding Office Action mailed March 22, 2001, please enter  
the following remarks and amendments in the above-referenced patent application.

**IN THE CLAIMS**

Please amend claim 27 as follows. A marked up version of the amended claim, to show  
all the changes, is attached hereto on pages separate from the amendment in accordance with 37  
CFR 1.121(c)(1)(ii).

*B*  
27. (Amended) A method for removing organic contaminants from a substrate, the  
organic contaminants resulting from a previous lithographic step, the method comprising the  
steps of:

holding said substrate in a tank; and

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